

# Experimental determination of residual strains and stresses in 2G HTS wire

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Received May 18, 2024

Revised November 22, 2024

Accepted November 29, 2024

Using X-ray and neutron diffraction, residual strains and stresses were measured in the main components of the second generation high temperature superconducting (2G HTS) wire based on yttrium ceramics, which was produced at the National Research Center „Kurchatov Institute“ — in the stainless steel carrier tape,  $Y_{0.15}Zr_{0.85}O_2$  and  $CeO_2$  buffer layers, and the  $YBa_2Cu_3O_7$  superconducting layer. Their changes during the wire manufacturing process were traced. The reliability of the results obtained is confirmed by their consistency. The method presented in the work for determining internal strain and stress is universal and is suitable for wires with different carrier tapes, buffer and superconducting layers.

**Keywords:** 2G HTS, residual strain/stress, AISI 310S tape, YSZ,  $CeO_2$ , YBCO, X-ray diffraction, neutron diffraction.

DOI: 10.61011/TP.2025.04.61210.185-24

## Introduction

Second generation superconducting tape-wires based on the high-temperature superconductors  $RBa_2Cu_3O_{7-\delta}$ , where R — yttrium (YBCO) or rare-earth metal (REBCO), hereinafter referred to as 2G HTS are used today for manufacturing current-carrying elements of high-current cables designed to create plants with magnetic fields up to 20 T. They have a multilayer structure [1] with three main components:

1 — steel carrier tape-substrate with a thickness of several tens of microns which provides mechanical strength of the wire;

2 — single-crystal superconducting YBCO or REBCO layer with a thickness of about one micron which determines the conductive characteristics of the wire;

3 — buffer layers with a biaxial texture with a thickness from several microns to tenths of a micron which connect the superconducting layer with the carrier tape.

Other components of the wire perform protective and stabilizing functions.

When operating in strong magnetic fields, 2GHTS must withstand high tensile stresses without loss of current-carrying capacity. As a result of systematic tensile tests of wires with different carrier tapes, buffer and superconducting layers at temperatures from 4.2 to 300 K it was established that the electromechanical stability of the wire is ensured not only by the carrier tape but also by internal (residual) strains and stresses in the superconducting and buffer layers. Thus, the internal strain in the buffer layers affects the current-carrying capacity of the wire [2]. Internal strain in the superconducting layer

prevents its destruction [3–7], which is also evidenced by the increased electromechanical stability of wires with a thin superconducting layer [8]. In addition to internal strain, the electromechanical properties of the wire are affected by the elastic domain microstructure in the superconducting layer [8–11], which changes under external load [12,13]. It is natural to think that it determines the internal strain in the superconducting layer.

Despite the importance of residual strains for 2GHTS, direct information about them is extremely limited and obtained indirectly through mechanical tests, and only for the superconducting layer [4–7]. As for residual stresses, just nothing is known about them. In order to get a complete representation about the residual strains and stresses, it is necessary to directly measure them in all components of the wire, which would seem unrealistic.

Previously, [14–16], we have developed and tested procedures which allow us to experimentally determine residual stresses and strains in separate components of 2GHTS.

Here we present the results obtained for the finished 2GHTS produced on the experimental technological line in the National Research Center „Kurchatov Institute“.

## 1. Methodology

### 1.1. Sample

The YBCO-based 2GHTS sample looked like this. A carrier tape was made of AISI 310S stainless steel. After several cycles of its polishing, a basic buffer layer of yttrium-stabilized zirconium dioxide  $Y_{0.15}Zr_{0.85}O_2$  (YSZ) was applied to one of its side using the ABAD technique

**Table 1.** The main stages of 2GHTS manufacturing and the characteristics of the samples studied in the process

Sample	Designation	Manufacturing stage and sample characteristics	Ref. Research ref.
Initial tape AISI 310S	—	As supplied, cold-rolled semi-work-hardened. Thickness 100 $\mu\text{m}$ , width 4 mm	[14–16]
Polished tape AISI 310S	#32	Several cycles of polishing by water suspension $\text{Al}_2\text{O}_3$ 1–0.3 $\mu\text{m}$ at the room temperature. Thickness about 98 $\mu\text{m}$	[15,16]
Tape with the basic buffer YSZ layer	YSZ#32	#32 + (layer of YSZ, ABAD 50 °C/36 h, the thickness 2.1 $\mu\text{m}$ )	[15,16]
2GHTS	HTSC#272	YSZ#32 + (layer of $\text{CeO}_2$ , PLD 700 °C/1 h, thickness 0.25 $\mu\text{m}$ ) + (layer of YBCO, PLD 750 °C/2 h, thickness 1.3 $\mu\text{m}$ ) + (layer of Ag, thermal sputtering, 100–150 °C, thickness 1.5 $\mu\text{m}$ ) + annealing in oxygen 420 °C/2 h	Present work

(Alternating Beam Assisted Deposition). An additional buffer layer of  $\text{CeO}_2$  and a subsequent superconducting layer of YBCO were applied to YSZ using the PLD method (Pulse Laser Deposition). The superconducting layer was protected by a layer of silver applied by thermal sputtering. After that the finished wire was annealed in an oxygen atmosphere. The main stages of wire manufacturing and the characteristics of the samples studied in the process are shown in Table 1.

## 1.2. Procedures

The methods for determining residual strains and stresses in 2GHTS components are described in detail in [14,16]. Let us briefly note the main points necessary for understanding the presented results.

- Residual stresses in thin layers, which are the buffer and superconducting layers of the wire, are determined using X-ray diffraction by strain they cause — the change in the distances  $d$  between the crystalline planes ( $hkl$ ) [16].

- In single-crystal layers, strain and stress depend on the elastic constants of the crystal — the stiffness constants  $c_{ij}$  and the associated compliance constants  $s_{ij}$ . The elastic constants are specified in the unit cell of the crystal (the crystal coordinate system), the indices  $i, j = 1, 2, 3$  correspond to its axes  $a, b, c$ .

- For layers with a cubic unit cell and a (001) interface with the substrate, as in YSZ and  $\text{CeO}_2$ , the strain and stress are isotropic. For any direction in the plane of the layer

$$\varepsilon_\psi = \frac{d_\psi - d_0}{d_0} = \sigma[2s_{12} + (s_{11} - s_{12}) \sin^2 \psi], \quad (1)$$

where  $\varepsilon_\psi$  and  $\sigma$  — the relative strain and average stress in the layer,  $d_0$  and  $d_\psi$  — the interplanar distances in the unstressed and stressed layer,  $\psi$  — the angle between the normal to the layer plane and the scattering vector perpendicular to the reflecting crystal plane.

- For a superconducting YBCO layer with an orthorhombic unit cell and a (001) interface with the substrate, the strain and stress are anisotropic [17]:

$$\varepsilon_\psi = A_1 \sigma_{11} + A_2 \sigma_{22}, \quad (2)$$

$$A_1 = -\frac{\nu_{13}}{E_1} + \frac{1}{E_1}[(1 + \nu_{12}) \cos^2 \xi + (\nu_{13} - \nu_{12})] \sin^2 \psi,$$

$$A_2 = -\frac{\nu_{23}}{E_2} + \frac{1}{E_2}[(1 + \nu_{21}) \sin^2 \xi + (\nu_{23} - \nu_{21})] \sin^2 \psi,$$

$$E_1 = \frac{c_{11}c_{22}c_{33} + 2c_{23}c_{12}c_{13} - c_{11}c_{23}^2 - c_{22}c_{13}^2 - c_{33}c_{12}^2}{c_{22}c_{33} - c_{23}^2},$$

$$E_1 = \frac{c_{11}c_{22}c_{33} + 2c_{23}c_{12}c_{13} - c_{11}c_{23}^2 - c_{22}c_{13}^2 - c_{33}c_{12}^2}{c_{11}c_{33} - c_{13}^2},$$

$$\nu_{12} = \frac{c_{12}c_{33} - c_{13}c_{23}}{c_{22}c_{33} - c_{23}^2},$$

$$\nu_{21} = \frac{c_{12}c_{33} - c_{13}c_{23}}{c_{11}c_{33} - c_{13}^2},$$

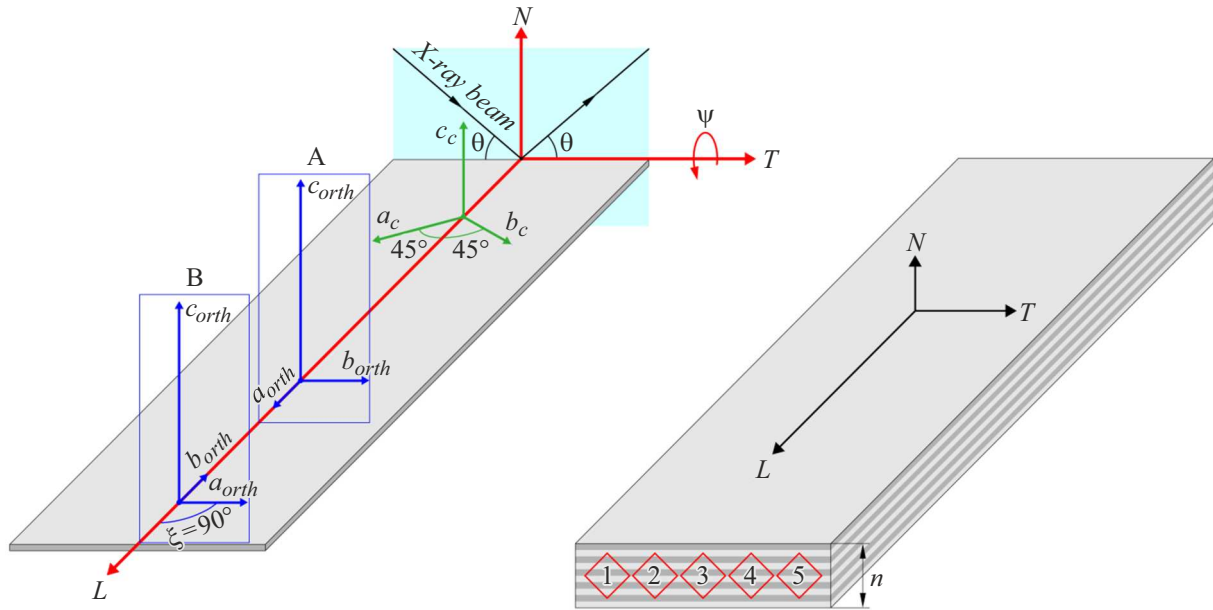
$$\nu_{13} = \frac{c_{22}c_{13} - c_{12}c_{23}}{c_{22}c_{33} - c_{23}^2},$$

$$\nu_{23} = \frac{c_{11}c_{23} - c_{12}c_{13}}{c_{11}c_{33} - c_{13}^2},$$

where  $\sigma_{11}$  and  $\sigma_{22}$  — the stresses along the  $a$  and  $b$  axes of the orthorhombic cell,  $\xi$  — the angle between the direction in the layer and the  $a$  axis of the cell,  $E_i$  and  $\nu_{ij}$  — the generalized Young's moduli and Poisson's ratios [18], the indices  $i, j = 1, 2, 3$  correspond to the axes  $a, b, c$  of the orthorhombic cell.

In our case (see Fig. 1, on the left and Section 1.3), the axis  $a$  is directed either along the wire (in A domains,  $\xi = 0$ ) or across it (in B domains,  $\xi = 90^\circ$ ). The strain  $\varepsilon_\psi$  is measured along the wire. For A domains

$$\varepsilon_\psi^{(A)} = \text{const} + \left( \frac{1 + \nu_{13}}{E_1} \sigma_{11} + \frac{\nu_{23} - \nu_{21}}{E_2} \sigma_{22} \right) \sin^2 \psi, \quad (3.1)$$



**Figure 1.** On the left — the setup of X-ray experiments and the used coordinate systems.  $L, T, N$  — laboratory coordinate system.  $a_c, b_c, c_c$  — crystal coordinate system for YSZ and  $\text{CeO}_2$  buffer layers.  $a_{orth}, b_{orth}, c_{orth}$  — crystal coordinate system for YBCO superconducting layer, A ( $\xi = 0^\circ$ ) and B ( $\xi = 90^\circ$ ) domains. The mutual orientation of the laboratory and crystal systems is specified by the layer application technique. The residual strain in the layers was measured along  $L$ , on the planes of the crystal zones, the axes of which are parallel to  $T$ , the Bragg reflections from the planes were measured using the usual  $\theta - 2\theta$  scheme in the scattering plane ( $T, N$ ). On the right — the sample used in the neutron diffraction experiment: a packet of  $n = 11$  wire segments. The arrows show the directions along ( $L$ ), across ( $T$ ) the rolling of the carrier tape and along the normal ( $N$ ) to its plane (they coincide with the laboratory coordinate system). The probe volumes (points) in which the measurements were taken are numbered; their sections are shown in the plane ( $T, N$ ), the sections in the plane ( $L, N$ ) are the same. Details in the text.

for B domains

$$\varepsilon_\psi^{(B)} = \text{const} + \left( \frac{\nu_{13} - \nu_{12}}{E_1} \sigma_{11} + \frac{1 + \nu_{23}}{E_2} \sigma_{22} \right) \sin^2 \psi, \quad (3.2)$$

$$\text{where } \text{const} = - \left( \frac{\nu_{13}}{E_1} \sigma_{11} + \frac{\nu_{23}}{E_2} \sigma_{22} \right).$$

When we have measured  $\varepsilon_\psi^{(A)}$  and  $\varepsilon_\psi^{(B)}$ , using the coefficients at  $\sin^2 \psi$  in (3.1) and (3.2) we can calculate  $\sigma_{11}$  and  $\sigma_{22}$ .

- In single-crystal layers, the strain  $\varepsilon_\psi$  is determined by the CGM (Crystallite Group Method) using crystal planes from different groups  $\{hkl\}$ , for details see [16]. If the conditions of the problem allow, it is convenient to use the planes of one crystal zone which includes a crystal plane parallel to the layer surface. The sample is rotated around the zone axis by angles  $\psi$  corresponding to the angles between the planes of the zone, and the interplanar distances are successively measured  $d_\psi = d_{hkl}$ .

- The residual strain  $\varepsilon_\psi$  is measured directly. The residual stress  $\sigma$  can be determined only if the elastic constants of the crystal are known. The elastic constants used in the present work are given in Tables 2.1 and 2.2. For YSZ the values are taken from [16], for  $\text{CeO}_2$  they are determined similarly to [16] by data from [19–24], for YBCO they are calculated using formulas (2) and data from [25].

- The residual strain in the carrier tape of the wire  $\varepsilon = (d - d_0)/d_0$  (where  $d_0$  and  $d$  — the interplanar distances in the unstressed and stressed tape) is measured using neutron diffraction [14,15]. Suitable reflections  $hkl$  are used for the measurements. At each point of the sample, three strain components are measured:  $\varepsilon_L$ ,  $\varepsilon_T$  and  $\varepsilon_N$  — along ( $L$ ), across ( $T$ ) the rolling and along normal ( $N$ ) to the tape plane. Then they are taken to calculate the stress components

$$\sigma_i = E \frac{(1 - 2\nu)\varepsilon_i + \nu(\varepsilon_T + \varepsilon_N + \varepsilon_L)}{(1 + \nu)(1 - 2\nu)}, \quad (4)$$

where  $E$  — Young's modulus,  $\nu$  — Poisson's ratio,  $i = L, T, N$ . For the AISI 310S stainless steel:  $E = 200 \text{ GPa}$ ,  $\nu = 0.27$  [26], the measurements are carried out on reflections from the planes  $\{311\}$ .

- The reliability of determining the residual stresses in 2GHTS can be evaluated by the degree of consistency of the results obtained by different methods for different components of the wire [16].

### 1.3. X-ray measurements

The measurements were performed in the resource center of the laboratory X-ray methods „Roentgen“ of the National

**Table 2.1.** Elastic stiffness constants  $c_{ij}$  and calculated compliance constants  $s_{ij}$  for cubic YSZ and CeO<sub>2</sub> single crystals

	$c_{11}$ , GPa	$c_{12}$ , GPa	$s_{11}$ , GPa <sup>-1</sup>	$s_{12}$ , GPa <sup>-1</sup>
YSZ	405.8(8.1)	95.5(13.9)	0.00271(7)	-0.00052(7)
CeO <sub>2</sub>	390.9(42.1)	124.8(24.7)	0.00307(37)	-0.00074(14)

Note. For YSZ the values are taken from [16], for CeO<sub>2</sub> they are determined similarly to [16] using the original data [19–24]. The brackets contain standard deviations and errors in last characters.

**Table 2.2.** Elastic stiffness constants  $c_{ij}$  for an orthorhombic YBCO single crystal (error for  $c_{33}$  7%, in other cases 0.3%) [25] and the generalized Young's moduli  $E_i$  and Poisson's ratios  $\nu_{ij}$  calculated by the formulas (2)

	$c_{11}$ , GPa	$c_{22}$ , GPa	$c_{33}$ , GPa	$c_{12}$ , GPa	$c_{13}$ , GPa	$c_{23}$ , GPa
YBCO	231	268	186	132	71	95
	$E_1$ , GPa	$E_2$ , GPa	$\nu_{21}$	$\nu_{12}$	$\nu_{23}$	$\nu_{13}$
	162.1	174.5	0.470	0.436	0.332	0.159

Research Center „Kurchatov Institute“ [27] on the four-circle diffractometer Rigaku SmartLab using CuK $\alpha$ -radiation and a beam with a point focus of 100  $\mu$ m diameter at the room temperature. General details of sample preparation, the measurements and processing of the data obtained are given in [16]. The experimental setup is shown in Fig. 1, on the left.

The measurements were carried out in the laboratory coordinate system  $L$ ,  $T$ ,  $N$ , as defined by the wire geometry. The  $L$  and  $T$  axes are in the plane of the wire, along and across it, respectively, and the  $N$  axis is perpendicular to the wire plane.

The crystal coordinate systems, in which the elastic constants for YSZ, CeO<sub>2</sub> and YBCO are specified, are determined by the crystal symmetry. The crystal system  $a_c$ ,  $b_c$ ,  $c_c$  corresponds to the cubic symmetry of YSZ and CeO<sub>2</sub> (CaF<sub>2</sub> structure type). The crystal system  $a_{orth}$ ,  $b_{orth}$ ,  $c_{orth}$  corresponds to the orthorhombic symmetry of YBCO. The mutual orientation of the laboratory and crystal systems is specified by the layer application technique. The cubic axes  $a_c$  and  $b_c$  are in the wire plane at angles of 45° to the axes  $L$  and  $T$ , the axis  $c_c$  is directed along  $N$ . The orthorhombic axes  $a_{orth}$  and  $b_{orth}$  are also in the wire plane and the axis  $c_{orth}$  is directed along  $N$ . There are two possible orientations of the axes  $a_{orth}$  and  $b_{orth}$  relative to  $L$  and  $T$ , which differ in their rotation around the axis  $N$  by an angle of  $\xi = 90^\circ$ :

- (A) —  $a_{orth}$  along  $L$ ,  $b_{orth}$  along  $T$ ;
- (B) —  $a_{orth}$  along  $T$ ,  $b_{orth}$  along  $L$ .

They correspond to domains A and B formed by microtwins in the YBCO crystal [10,11,28].

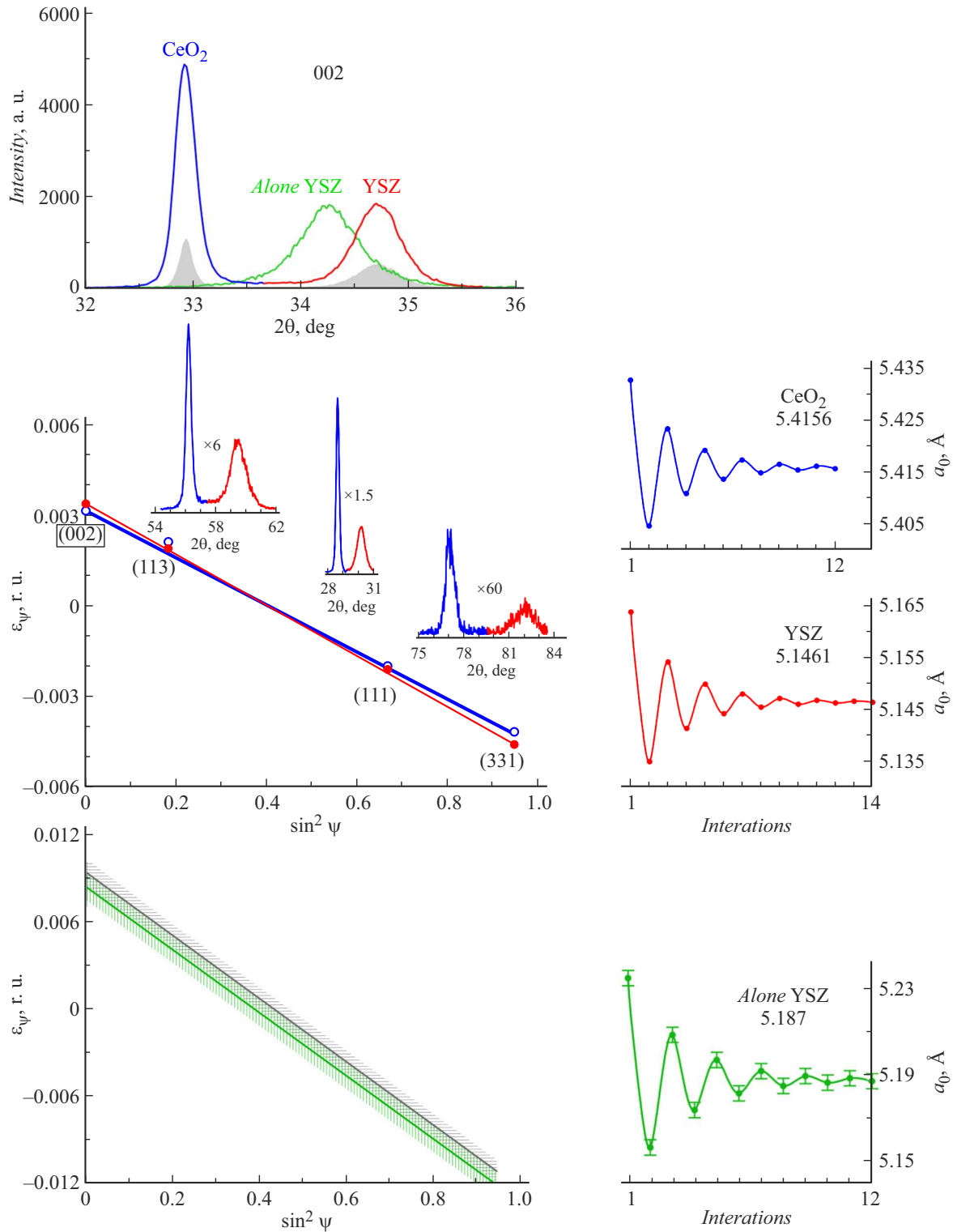
The strain  $\varepsilon_\psi$  was measured on the planes of the crystalline zones with axes directed along  $T$ , and the planes with the most strong reflections were selected. For the isostructural YSZ and CeO<sub>2</sub>, these are the (002), (113), (111), (331) planes which belong to the zone with the  $[1\bar{1}0]$

axis. For YBCO — the (001), (108), (103), (303) planes of the  $[010]$  zone for the domains A, and the (001), (018), (013), (033) planes of the  $[100]$  zone for the domains B. The transition from one crystal plane to another was performed by rotating the sample around the  $T$  axis by the respective angle  $\psi$ . The Bragg reflections were measured using the usual  $\theta - 2\theta$  scheme in the scattering plane ( $T$ ,  $N$ ) (marked in turquoise in Fig. 1).

Since the protective silver layer strongly absorbs CuK $\alpha$ -radiation and weakens the intensities of reflections in several times (Fig. 2), it was removed by etching the sample in the aqueous solution H<sub>2</sub>O<sub>2</sub> 30% (1 volume part) + NH<sub>4</sub>OH 3% (3 volume parts). According to X-ray and electron microscopic data, such etching did not affect the YSZ, CeO<sub>2</sub> and YBCO layers in any way.

#### 1.4. Neutron measurements

The measurements were carried out at the neutron stress diffractometry station STRESS [29] of the Kurchatov Neutron Research Complex IR-8 [30]. Sample preparation and measurement procedure are described in detail in [14,15]. The sample was a package of eleven wire segments of the same length of 50 mm (Fig. 1, on the right) which were cut from a single piece of the wire and successively laid on each other while maintaining the orientation relative to the wire side and the rolling direction of the carrier tape; the package was fixed in the aluminum case. Measurements were carried out through a layer of aluminum in five points (probe volumes) along the width of the wire, which were located in the middle of the length and thickness of the sample (the numbered points in Fig. 1). The single-crystal layers of YSZ, CeO<sub>2</sub> and YBCO in the wire, the total thickness of which is less than 4% of the wire thickness, are invisible for neutrons, so the strain inside the carrier tape was actually measured. As in the case of the tape with



**Figure 2.** Results of X-ray measurements for YSZ (red) and CeO<sub>2</sub> (blue) layers in 2GHTS, CuK<sub>α</sub>-radiation. For comparison, similar data for a single YSZ layer [16] are shown in green. At the top — Bragg reflections 002 in the sample without protective silver layer; reflections taken through a silver layer of 1.5 μm are shown in grey. In the center — relative strain  $\varepsilon_\psi$  for planes (002), (113), (111), (331) of the [110] crystal zone; symbols — experimental points, errors within the symbols; lines — approximating straight lines  $\varepsilon_\psi = k_0 + k_1 \sin^2 \psi$ , standard deviations within the line thicknesses. For each plane, profiles of Bragg reflections are shown (for the (002) planes — at the top); the scale on the intensity axis is the same in all cases (as for 002). The iterative dependences for determining the periods  $a_0$  for unstressed lattices are shown on the right. At the bottom — the data for a single YSZ layer [16], which correspond to the period  $a_0$  determined by the iterative method. Within the standard deviation (shaded area), they coincide with those determined in [16] (shown in grey). Details in the text.

**Table 3.** Residual strain and stress in the buffer and superconducting layers of 2GHTS

Layer	Parameters of unstressed unit cell, Å			Domains	Strain, rel. un. $\varepsilon_\psi = k_0 + k_1 \sin^2 \psi$		Stress, GPa
	$a_0$	$b_0$	$c_0$		$k_0$	$k_1$	
YSZ	5.1461(3)	—	—	—	0.0034(1)	−0.0084(2)	−2.60(16)
CeO <sub>2</sub>	5.4156(6)	—	—	—	0.0032(2)	−0.0080(4)	−2.09(38)
YBCO	3.8162(6)	3.8839(6)	11.668(2)	A	0.0073(2)	−0.0101(4)	Along the wire, $\sigma_{11}$ −1.63(16) Across the wire, $\sigma_{22}$ −1.98(19)
				B	0.0073(3)	−0.0123(6)	Along the wire, $\sigma_{22}$ −1.98(19) Across the wire, $\sigma_{11}$ −1.63(16)
				30 %A + 70 %B	—	—	Along the wire −1.88(18) Across the wire −1.74(17)

Note: The strain is represented as the linear function  $\varepsilon_\psi = k_0 + k_1 \sin^2 \psi$  (Fig. 2, 3). The stress is calculated by the coefficient  $k_1$  using the formulas (1), (3.1), (3.2) and the elastic constants of Tables 2.1 and 2.2. The brackets contain errors in last characters.

a single YSZ layer [15], the sample thickness was increased by an additional segment compared to the initial tape [14] because the wire is bent towards the single-crystal layers and there is a risk of output of the probe volume beyond the sample limits, especially during transverse (T) and normal (N) strain measurements when an increased-by-height probe volume is used [14].

## 2. Results

### 2.1. YSZ and CeO<sub>2</sub> layers

The experimental data for YSZ and CeO<sub>2</sub> layers are shown in Fig. 2. The main problem in determining the strain  $\varepsilon_\psi$  by the formula (1) is knowledge of the interplanar spacings  $d_0$  or, for a cubic lattice, the period  $a_0$  in the unstressed state. Unlike the tape with a single YSZ layer [15], in the finished wire it is impossible to experimentally produce unstressed states for the YSZ and CeO<sub>2</sub> layers. Therefore, for determination of  $a_0$  we used the following iterative method.

The isotropic strain  $\varepsilon_\psi$  in the YSZ and CeO<sub>2</sub> layers can be represented as [31]:

$$\varepsilon_\psi = \varepsilon_\perp + (\varepsilon_\parallel - \varepsilon_\perp) \sin^2 \psi,$$

where  $\varepsilon_\parallel$  and  $\varepsilon_\perp$  — the strain in the layer plane and perpendicular to it. Since  $\varepsilon_\psi \leq 1\%$  [16], the parameters of both the stressed and unstressed unit cell are close to  $a_\perp = 2d_{002}$ , where  $d_{002}$  — the measured distance between the (002) planes parallel to the layer surface ( $\psi = 0$ ). We take  $a_0 \approx a_\perp$ .

1) Approximate the experimental points with a straight line  $\varepsilon_\psi = k_0 + k_\perp \sin^2 \psi$

2) Extrapolate the approximating line to  $\psi = 90^\circ$  and obtain the strain in the layer plane  $\varepsilon_\parallel = k_0 + k_1$ .

3) Find the cell parameter in the layer plane  $a_\parallel = a_0(\varepsilon_\parallel + 1) \approx a_\perp(\varepsilon_\parallel + 1)$

4) Determine  $a_0$  for the next iteration:  $a_0 = (a_\perp a_\parallel^2)^{1/3} \approx a_\perp(\varepsilon_\parallel + 1)^{2/3}$

Steps 1–4 are repeated until the difference in the values of  $a_0$  for two consecutive iterations is equal to the accuracy of determining  $a_0$  in them. The result is achieved in less than 15 iterations (Fig. 2, on the right).

The method was successfully tested on data for a single YSZ layer [16] (Fig. 2, at the bottom). The obtained value  $a_0 = 5.187(4)$  Å is in satisfactory agreement with the experimental one, 5.182 Å, and the strain calculated with it coincides within the standard deviation with that determined in [16].

The results of processing the experimental data for the YSZ and CeO<sub>2</sub> layers are given in Table 3. The values of  $a_0$  are somewhat higher than for conventional crystals — by 0.22 % and 0.085 %, respectively. It is not surprising, especially for the basic buffer layer of YSZ whose lattice is initially strongly swelled [16]. The residual strain in both layers is compressive. The compressive stress in CeO<sub>2</sub> is less than in YSZ by approximately 20 %. The stress in YSZ is less than in a single layer [16] also by 20 %.

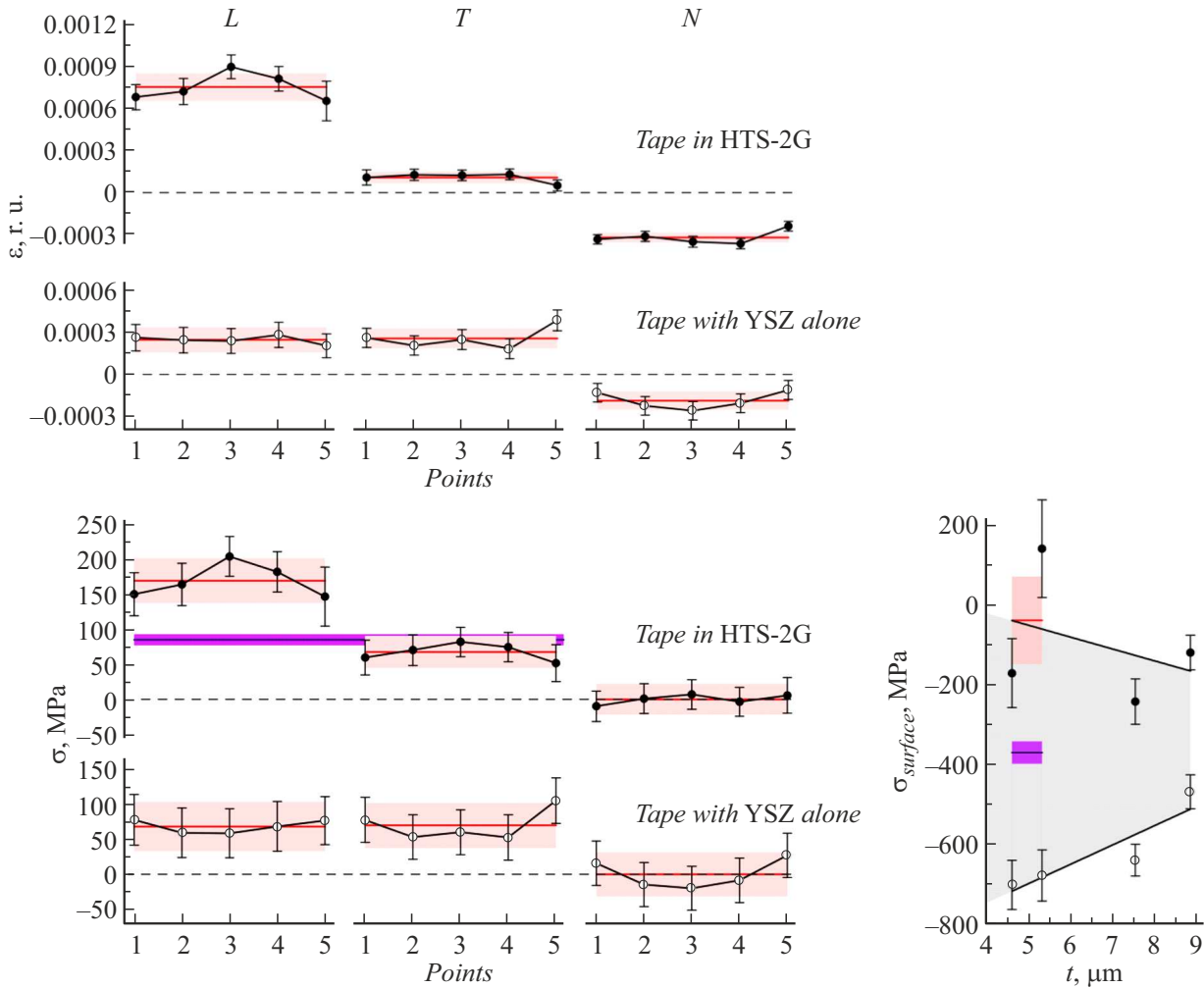
### 2.2. YBCO layer

Experimental data for the YBCO layer are shown in Fig. 3.

Unlike YSZ and CeO<sub>2</sub>, in YBCO the iteration method is not suitable for determining the parameters of the unstressed unit cell because there are three parameters:  $a_0$ ,  $b_0$  and  $c_0$ . Therefore, we applied a different approach using the ratio of these parameters for a conventional (unstressed) ceramics YBa<sub>2</sub>Cu<sub>3</sub>O<sub>7- $\delta$</sub>  [32–37] and the fact that the cell volume is preserved during the transition from the stressed to the unstressed state (since the residual stresses are elastic). In conventional ceramics,  $a_0 : b_0 : c_0 = 0.3271(5) : 0.3329(5) : 1$  [32–37] and, accordingly, the cell volume  $V_0 = a_0 b_0 c_0 = 0.1089(3)c_0^3$ . The







**Figure 4.** Residual strain  $\varepsilon$  and stress  $\sigma$  ( $L$ ,  $T$  and  $N$  components, Fig. 1) in the carrier tape in 2GHTS, in comparison with the data for the tape with a single YSZ layer [15]. The positions of the probe volumes (*Points*) are shown in Fig. 1. Symbols (black circles for tape in wire, white circles for tape with a single YSZ layer) — experimental points with errors, connected by lines for eye; mean values and standard deviation areas are shown in red. The value of  $\sigma$  with error, calculated from the X-ray data from Table 3, is shown in blue. In the inset at the bottom right — the stress  $\sigma_{\text{surface}}$  on tape surface under YSZ layer in the wire and in the tape with a single YSZ layer [16] depending on surface layer thickness  $t$ ; symbols — experimental points with errors, gray area corresponds to tensile stress. The value of  $\sigma_{\text{surface}}$  with error, determined from measured stress  $\sigma_L$ , is shown in red. The value of  $\sigma_{\text{surface}}$  with error, calculated from X-ray data, is shown in blue. Details in the text.

while a compressed layer is preserved on the surface of the tape. According to the estimate, the balance of elastic forces is achieved when a compressed layer thickness is about  $15 \mu\text{m}$  and an average stress in it is  $-360 \text{ MPa}$ . A layer with such parameters is invisible to neutrons [15], and only the additional tensile stress  $\Delta\sigma_L$  along the tape is observed.

The tension of the wire during the manufacturing process and subsequent annealing in this state naturally explain the predominance in the YBCO layer of B domains with higher compressive stress and a long axis of the unit cell along the wire. This is the result of minimization of elastic energy in the wire. Previously [12,13], a similar effect was observed in finished wires subjected to additional annealing under load.

## Conclusion

The main results:

1. Residual strains and stresses in the main components of the finished 2GHTS are measured for the first time. The wire was manufactured at the National Research Center „Kurchatov Institute“.

2. In the YSZ and  $\text{CeO}_2$  buffer layers and the YBCO superconducting layer, the strain and stress are compressive. The stress decreases from YSZ ( $-2.60 \text{ GPa}$ ) to  $\text{CeO}_2$  ( $-2.09 \text{ GPa}$ ) and YBCO ( $-1.81 \text{ GPa}$  in average), by 20 % and 14 %, respectively. In the superconducting layer, the domains with higher compressive stress and long axis of the unit cell along the wire predominate, they constitute 70 %.



3. In the AISI 310S carrier tape, the stress is tensile and highly anisotropic along (169 MPa) and across (68 MPa) the wire. Excessive longitudinal stretching is caused by conditions of wire manufacturing, which are responsible for predominance in the superconducting layer of domains with high compressive stress along the wire.

4. The reliability of the obtained results is confirmed by their consistency.

5. Simple methods for determining the parameters of unstressed state for 2GHTS main components, based on available data for stressed state, are proposed.

6. The method for determining internal strains and stresses in 2GHTS presented in the work is universal. It uses well-known proven procedures and is suitable for wires with different carrier tapes, buffer and superconducting layers.

## Acknowledgments

The authors are grateful to I.V. Kulikov for assistance in etching the wire.

## Funding

The work was carried out under state assignment of the National Research Center „Kurchatov Institute“.

## Conflict of interest

The authors declare that they have no conflict of interest.

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*Translated by M.Shevelev*